RECEIVED CENTRAL FAX CENTER

Docket No.: 063979-0032

FEB 2 7 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE UNDER 37 C.F.R. 1.116 **EXPEDITED PROCEDURE**

In re Application of

Customer Number: 20277

Yoshiaki HASEGAWA, et al.

Confirmation Number: 3843

Application No.: 10/643,944

Group Art Unit: 2828

Filed: August 20, 2003

Examiner: Tod Thomas VAN ROY

For: SEMICONDUCTOR LASER AND PROCESS FOR MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

13.27.06 13.27.06 13.06 In response to the Office Action dated November 25, 2005, having a three-month shortened statutory period for response set to expire February 25, 2006 (Saturday), please amend the above-identified application as follows:

PAGE 2/11 * RCVD AT 2/21/2005 11:54:12 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-U1 * DNIS:2738300 * CSID:202 755 8097 * DURATION (mm-ss):03-00